

BS EN 60749-21:2011



BSI Standards Publication

Semiconductor devices — Mechanical and climatic test methods

Part 21: Solderability

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National foreword

This British Standard is the UK implementation of EN 60749-21:2011. It is identical to IEC 60749-21:2011. It supersedes BS EN 60749-21:2005 which is withdrawn.

The UK participation in its preparation was entrusted to Technical Committee EPL/47, Semiconductors.

A list of organizations represented on this committee can be obtained on request to its secretary.

This publication does not purport to include all the necessary provisions of a contract. Users are responsible for its correct application.

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Compliance with a British Standard cannot confer immunity from legal obligations.

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English version

**Semiconductor devices -
Mechanical and climatic test methods -
Part 21: Solderability
(IEC 60749-21:2011)**

Dispositifs à semiconducteur -
Méthodes d'essai mécaniques et
climatiques -
Partie 21: Brasabilité
(CEI 60749-21:2011)

Halbleiterbauelemente -
Mechanische und klimatische
Prüfverfahren -
Teil 21: Lötbarkeit
(IEC 60749-21:2011)

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European Committee for Electrotechnical Standardization
Comité Européen de Normalisation Electrotechnique
Europäisches Komitee für Elektrotechnische Normung

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Foreword

The text of document 47/2082/FDIS, future edition 2 of IEC 60749-21, prepared by IEC TC 47, Semiconductor devices, was submitted to the IEC-CENELEC parallel vote and was approved by CENELEC as EN 60749-21 on 2011-05-12.

This European Standard supersedes EN 60749-21:2005.

EN 60749-21:2011 cancels and replaces EN 60749-21:2005 and constitutes a technical revision. The significant change is the inclusion of Pb (lead)–free backward compatibility.

Attention is drawn to the possibility that some of the elements of this document may be the subject of patent rights. CEN and CENELEC shall not be held responsible for identifying any or all such patent rights.

The following dates were fixed:

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|--|-------|------------|
| – latest date by which the EN has to be implemented at national level by publication of an identical national standard or by endorsement | (dop) | 2012-02-12 |
| – latest date by which the national standards conflicting with the EN have to be withdrawn | (dow) | 2014-05-12 |

Annex ZA has been added by CENELEC.

Endorsement notice

The text of the International Standard IEC 60749-21:2011 was approved by CENELEC as a European Standard without any modification.

In the official version, for Bibliography, the following notes have to be added for the standards indicated:

IEC 60068 series	NOTE	Harmonized in EN 60068 series.
IEC 60068-2-69:2007	NOTE	Harmonized as EN 60068-2-69:2007 (not modified).
IEC 60749 series	NOTE	Harmonized in EN 60749 series.
IEC 60749-15:2003	NOTE	Harmonized as EN 60749-15:2003 (not modified).
IEC 60749-20:2008	NOTE	Harmonized as EN 60749-20:2009 (not modified).

Annex ZA (normative)

Normative references to international publications with their corresponding European publications

The following referenced documents are indispensable for the application of this document. For dated references, only the edition cited applies. For undated references, the latest edition of the referenced document (including any amendments) applies.

NOTE When an international publication has been modified by common modifications, indicated by (mod), the relevant EN/HD applies.

<u>Publication</u>	<u>Year</u>	<u>Title</u>	<u>EN/HD</u>	<u>Year</u>
IEC 61190-1-2	2007	Attachment materials for electronic assembly - Part 1-2: Requirements for soldering pastes for high-quality interconnects in electronics assembly	EN 61190-1-2	2007
IEC 61190-1-3	2007	Attachment materials for electronic assembly - Part 1-3: Requirements for electronic grade solder alloys and fluxed and non-fluxed solid solders for electronic soldering applications	EN 61190-1-3	2007

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SEMICONDUCTOR DEVICES – MECHANICAL AND CLIMATIC TEST METHODS –

Part 21: Solderability

1 Scope

This part of IEC 60749 establishes a standard procedure for determining the solderability of device package terminations that are intended to be joined to another surface using tin-lead (SnPb) or lead-free (Pb-free) solder for the attachment.

This test method provides a procedure for 'dip and look' solderability testing of through hole, axial and surface mount devices (SMDs) as well as an optional procedure for a board mounting solderability test for SMDs for the purpose of allowing simulation of the soldering process to be used in the device application. The test method also provides optional conditions for ageing.

This test is considered destructive unless otherwise detailed in the relevant specification.

NOTE 1 This test method is in general accord with IEC 60068, but due to specific requirements of semiconductors, the following text is applied.

NOTE 2 This test method does not assess the effect of thermal stresses which may occur during the soldering process. Reference should be made IEC 60749-15 or IEC 60749-20.

2 Normative references

The following referenced documents are indispensable for the application of this document. For dated references, only the edition cited applies. For undated references, the latest edition of the referenced document (including any amendments) applies.

IEC 61190-1-2:2007, *Attachment materials for electronic assembly – Part 1-2: Requirements for soldering pastes for high-quality interconnects in electronics assembly*

IEC 61190-1-3:2007, *Attachment materials for electronic assembly – Part 1-3: Requirements for electronic grade solder alloys and fluxed and non-fluxed solid solders for electronic soldering applications*

3 Test apparatus

This test method requires the following equipment.

3.1 Solder bath

The solder bath shall be not less than 40 mm in depth and not less than 300 ml in volume such that it can contain at least 1 kg of solder. The apparatus shall be capable of maintaining the solder at the specified temperature within ± 5 °C.

3.2 Dipping device

A mechanical dipping device capable of controlling the rates of immersion and emersion of the terminations and providing a dwell time (time of total immersion to the required depth) in the solder bath as specified shall be used.